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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Joon Hyeon LEE

Serial No.: 10/731,482

Group Art Unit: 2812

Filed: December 10, 2003

Examiner: Gurley, Lynne Ann

For: METHOD OF FORMING METAL LINE LAYER IN SEMICONDUCTOR DEVICE

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AMENDMENT AFTER FINAL REJECTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 24, 2005

Sir:

Responsive to the Office Action mailed January 25, 2005,
kindly enter the following amendments and remarks.